Sheet 1 of 1 FORM PT 1449 IREV. 7.80 1 7 2003 U.S. Department of Commerce PATE AND TRADEMARK OFFICE Serial No.: Attorney Docket No.: 15.55/6364 10/050,793 Applicant: INFORMATION DISORDSURE STATEMENT **EBINA** (Use several sheets if necessary) Group: Filing Date: Jan. 18, 2002 2815 **U.S. PATENT DOCUMENTS** Filing Date if Examiner **Document Number** Date Name Class Sub-Initial Class Appropriate M Malhi 0 8 6 5 31Aug93 5 Th 6 2 6 0 12Jun01 Tsuda et al. Th 5 9 8 8 5 4 7Dec99 Morishita et al. nu 2002/ 01 0 0 9 7Feb02 Oue et al. Th Subrahmanyan et al. 5 5. 9 0 8 3 17Oct95 N 2 3Sep96 Skotnicki et al. 5 5 5 6 4 TB 6 2 2 6 6 1May01 Endo et al. 5 TV 15May01 FOREIGN PATENT DOCUMENTS Translation **Document Number Date** Country Class Sub-Class No Yes m abst. 62-10Jun87 2 8 5 6 1 Japan **OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.) Notice of Reasons of Rejection for Japanese Patent Application No. 2001-011858 (from which priority is claimed in U.S. Serial No. 10/050,792), which cites JP05-041488 and JP05-218316, which were previously cited in an IDS. TV 70 Notice of Reasons of Rejection for Japanese Patent Application No. 2000-382395 (from which priority is claimed in U.S. Serial No. 10/014,612), which cites JP05-041488 and JP05-218316, which were previously cited in an IDS. Parke et al., "Bipolar-FET Hybrid-Mode Operation of Quarter-Micrometer SOI MOSFET's," *IEEE Electron Device Letters*, Vol. 14, No. 5, May 1993, pp. 234-236. 78 Date Considered 14/8/03 Examiner,

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